

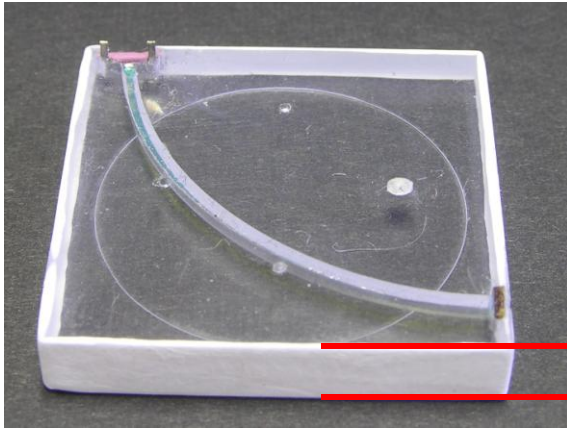
**CALICE Meeting, Casablanca, 23 Sep 2010**

**Scintillator tile – SiPM  
development at ITEP**

**Michael Danilov, ITEP**

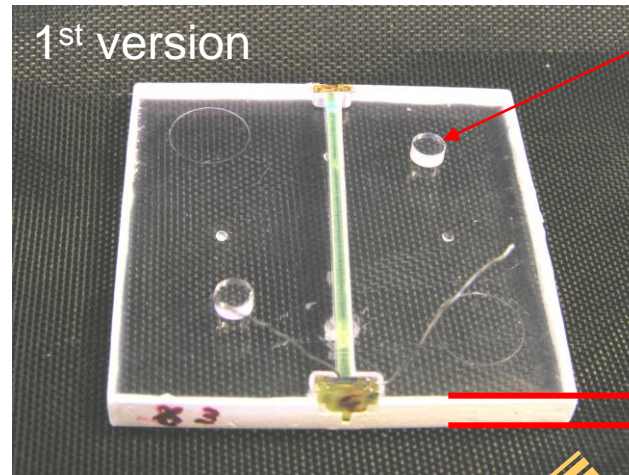
# Development of new tile

CALICE



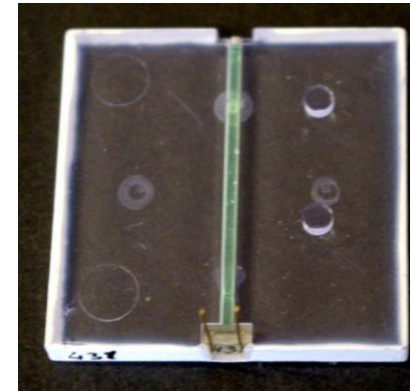
5mm

EUDET



3mm

2nd version



**Tile thickness: 5mm → 3mm (smaller total HCAL thickness).**

**Alignment pins**

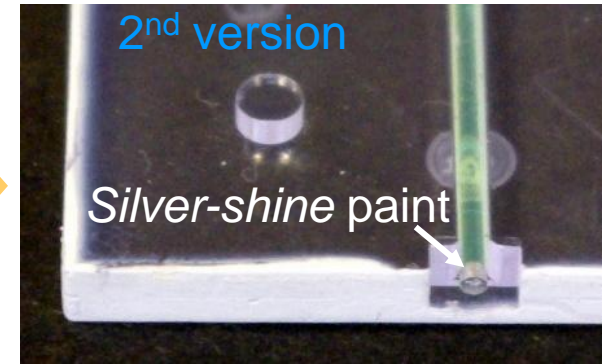
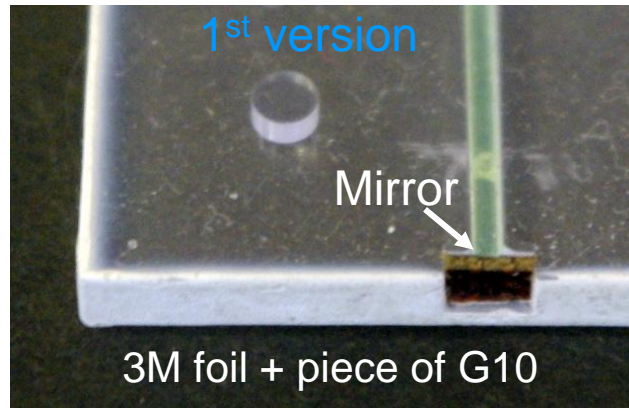
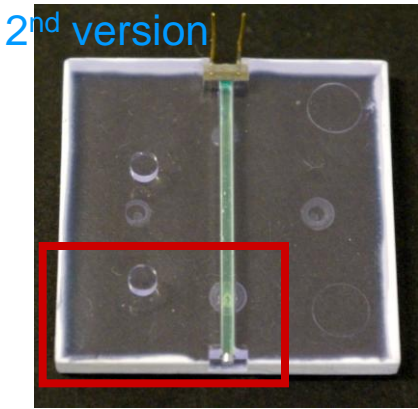
*(for simple and reliable connection to PCB).*

**Less labor active production**

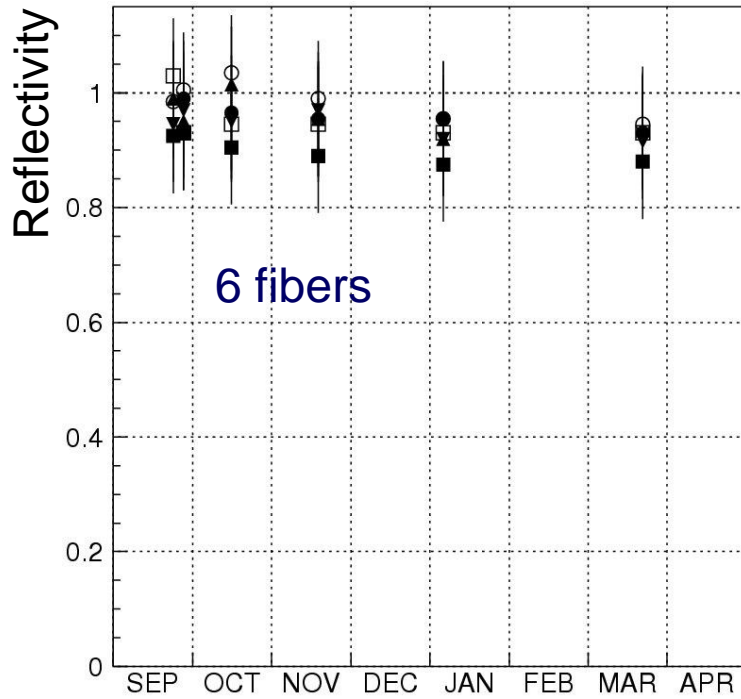
*(milling → casting, silver paint mirror).*

# Mirror at far end of WLS fiber

∅ 1mm Kuraray



Reflectivity ~ 90%

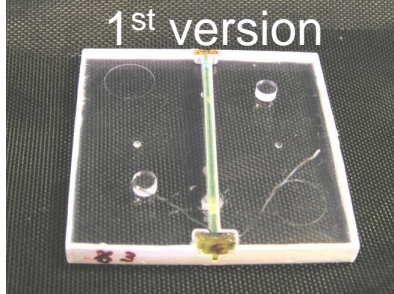


Long term stability

Reflectivity measured using tile and <sup>90</sup>Sr  
(mirrored and blackened fibers light yield ratio)

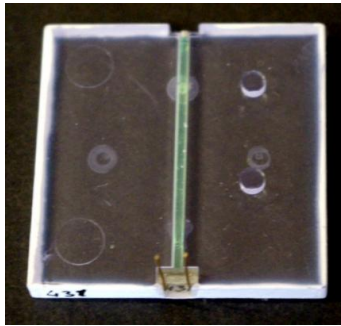
Enormous simplification of mass production.

# Tiles production status



144 tiles in Dec 2008  
*(used in engineering prototype)*

2<sup>nd</sup> version



Test samples of new tiles were sent to DESY to check mechanical tolerances.

20 fully equipped 2<sup>nd</sup> version tiles have been sent to DESY in September  
~1000 next version tiles – Feb 2011

All SiPMs are delivered

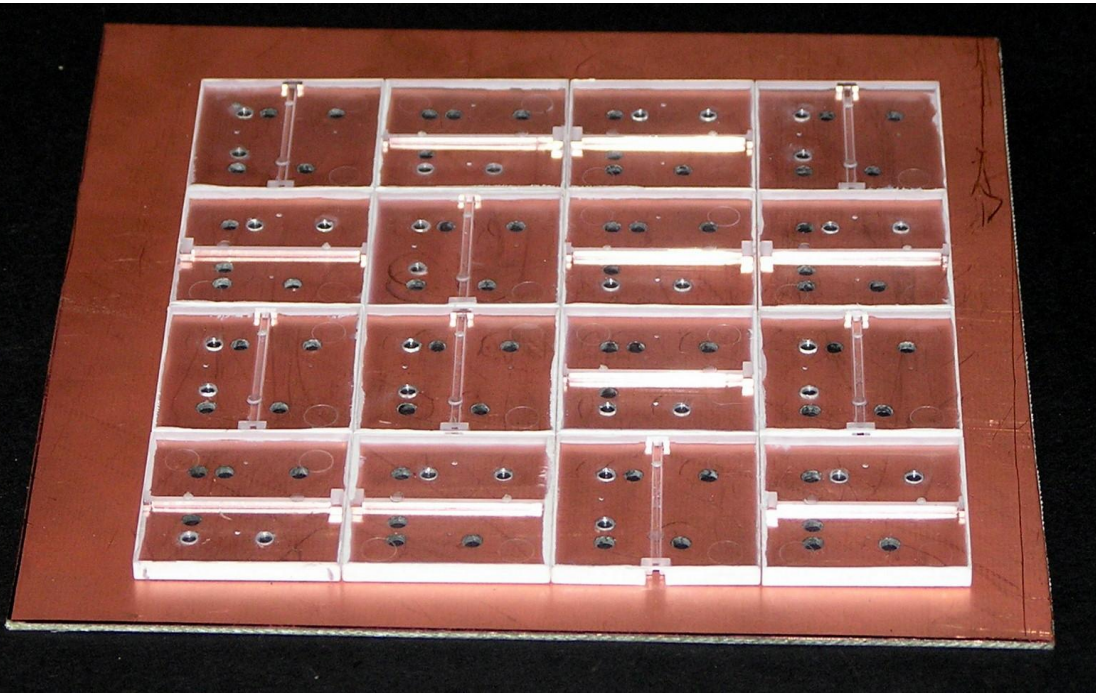
All tiles are produced and edges matted

Now final assembly at ITEP

# Accuracy in tile sizes

Measurements at DESY indicated wrong tile sizes – excitement at last HCAL meeting

Fortunately it was just a measurement error



*Model of tile connection to PCB*

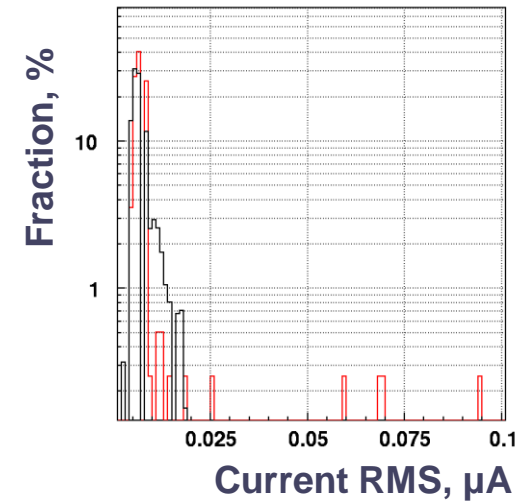
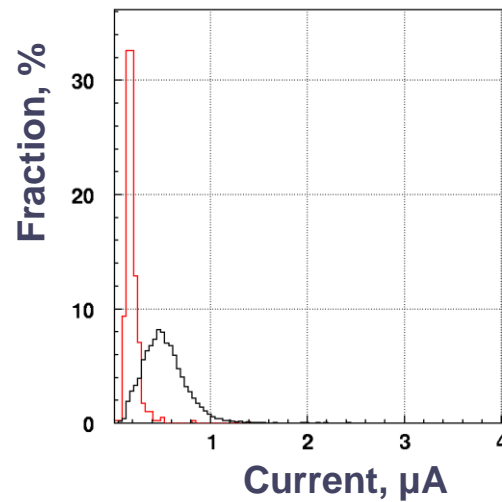
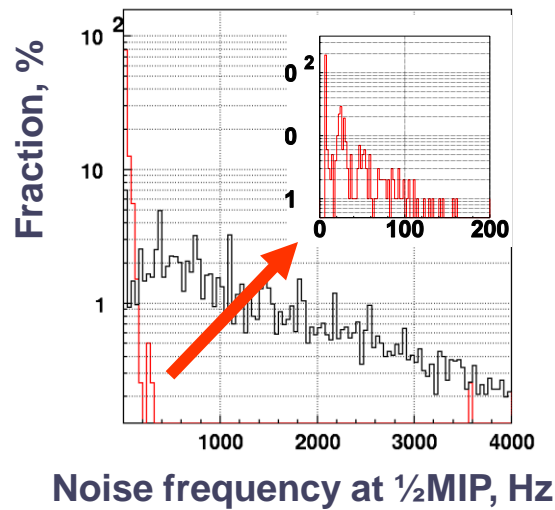
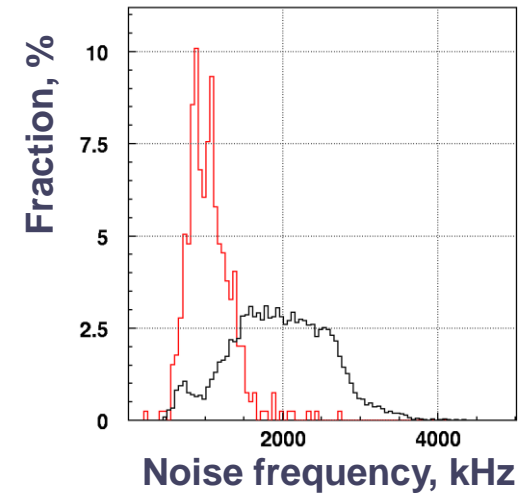
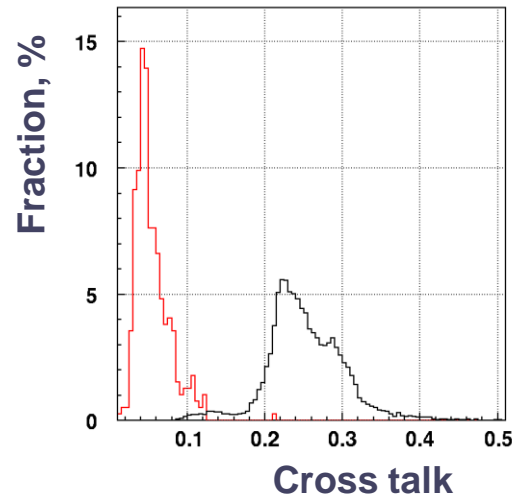
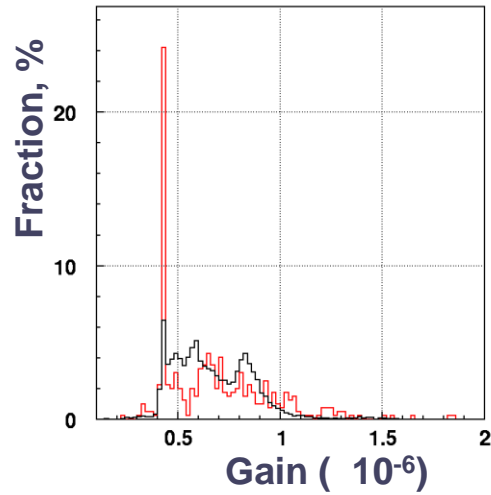
- plate produced by programmable milling machine (*accuracy 10 $\mu$ m*)
- pitch 30.10mm  
(nominal size + 100 $\mu$ m tolerance)
- extra holes to allow arbitrary orientation of tile tiles with matted edges

**Good accuracy in tile sizes achieved.**

**Detector plane can be assembled assuming 100 $\mu$ m tolerance.**

Final hole pattern will be selected using test PCBs

# Comparison of parameters of **MEPh/Pulsar** and **CPTA** (556pixel) SiPMs.



**CPTA SiPMs are next generation devices.**

# Development of new CPTA photosensor

**CPTA SiPM** – 556 cells

**MEPhI/Pulsar** – 1156 (900 effective) cells

To improve dynamic range:

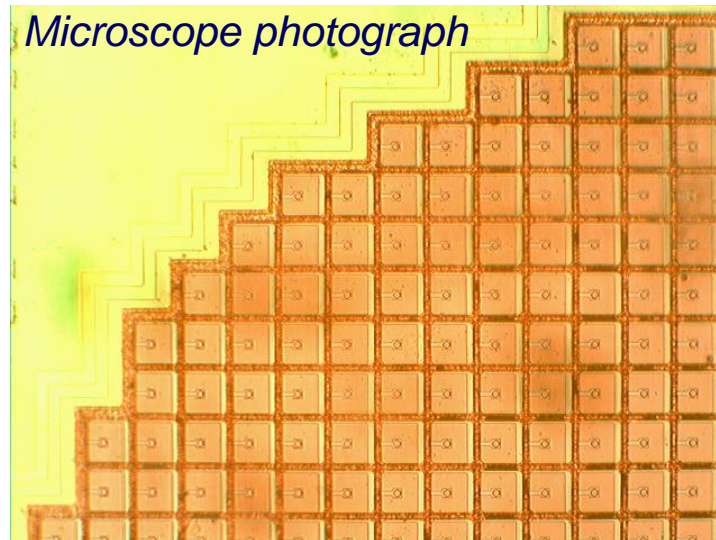
working point 13p.e. /MIP  
→ 10p.e. /MIP

**New sensor**

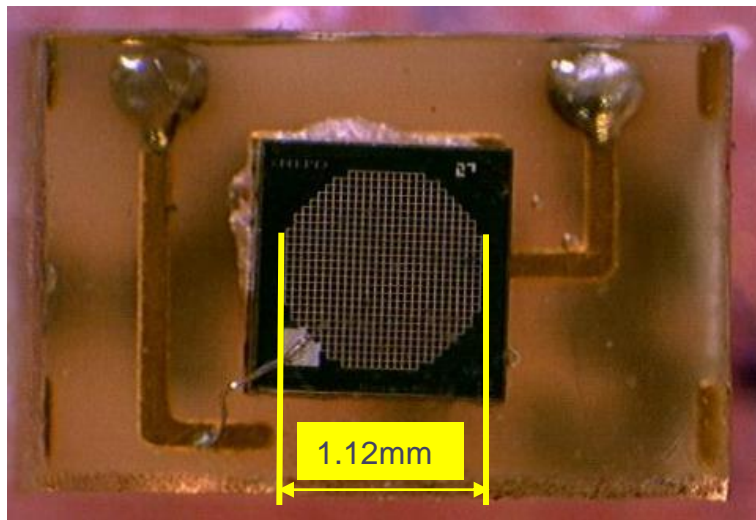
#pixels 556 → 796

pixel size  $43\mu$  →  $40\mu$

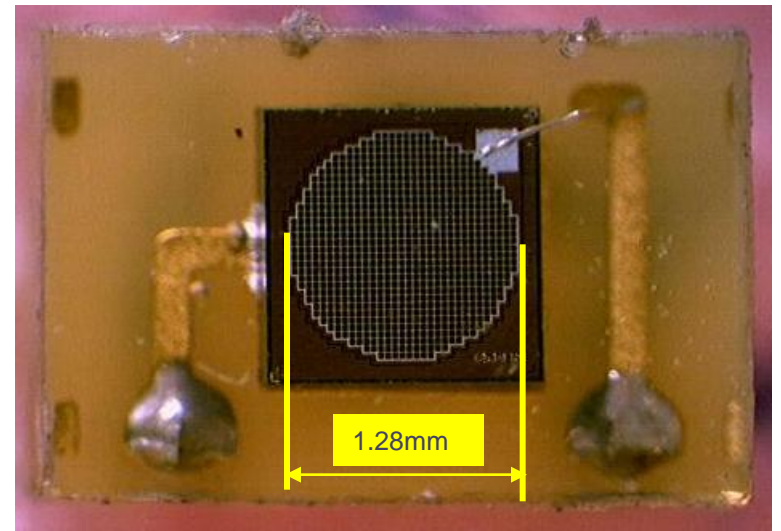
sensitive area  $\varnothing$  1.1mm → 1.28mm



556 pixel MRS APD



796 pixel MRS APD



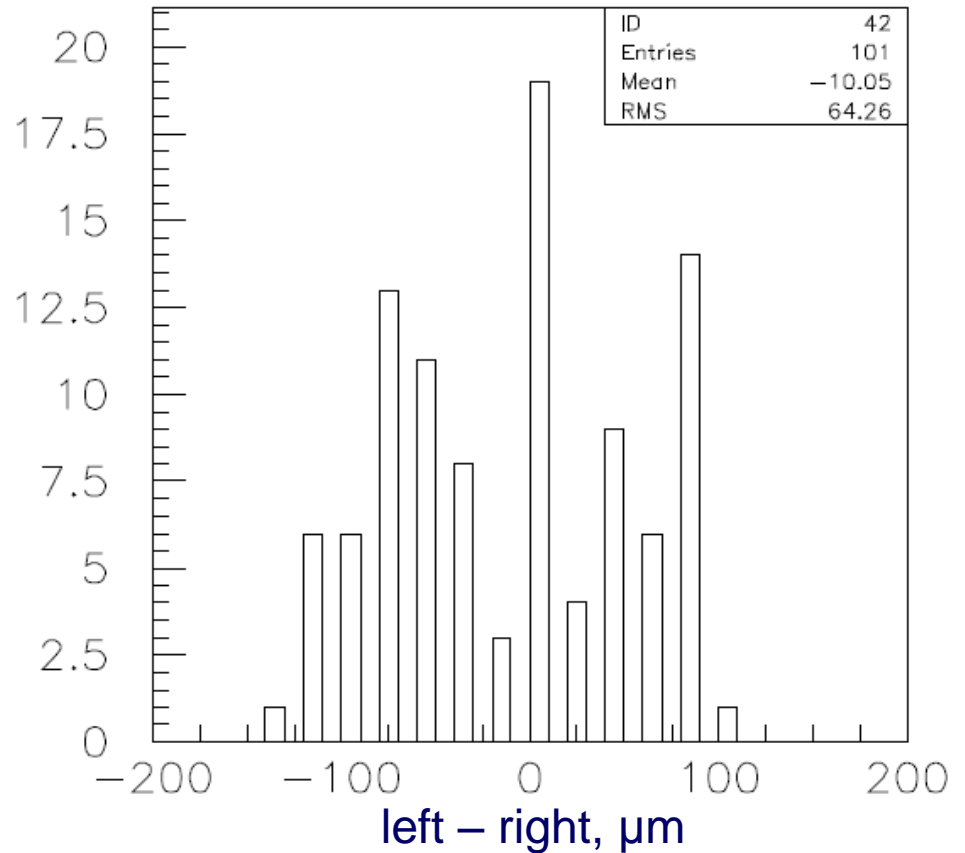
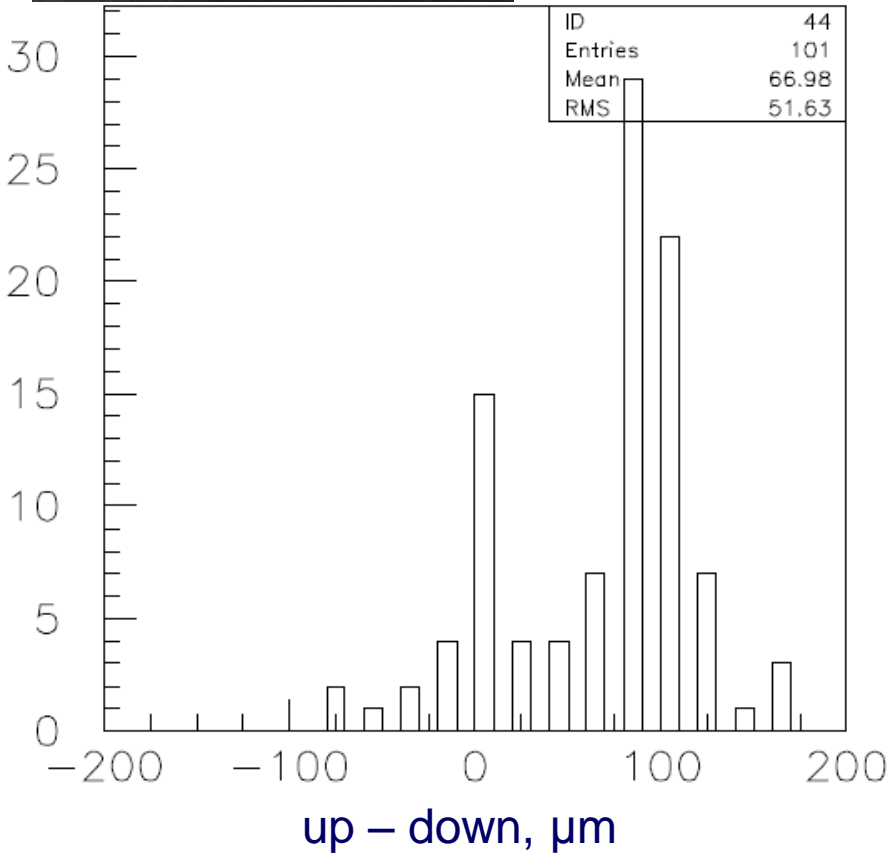
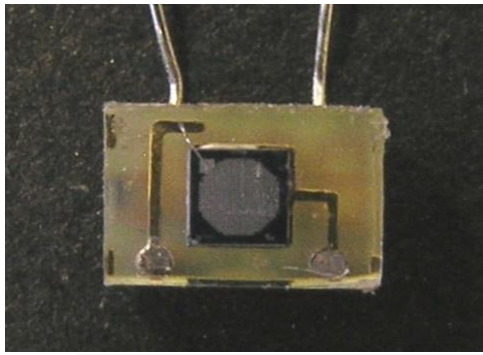
- Better matching to 1.2 mm WLS fiber
- Increase dynamic range
- Better parameters



# New package

Size:  $4 \times 2.6 \times 1.6 \text{ mm}^3$  ← tolerance  $20\mu\text{m}$

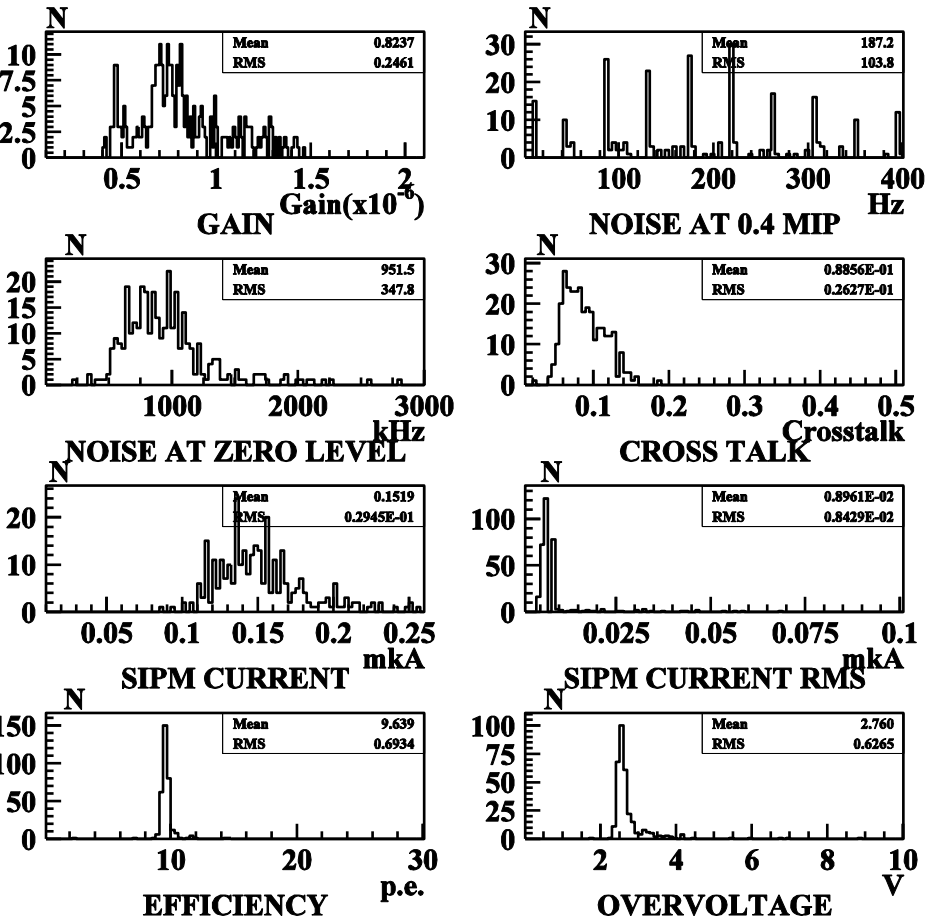
Shifts of sensitive area relative to package edges  
measured using microscope



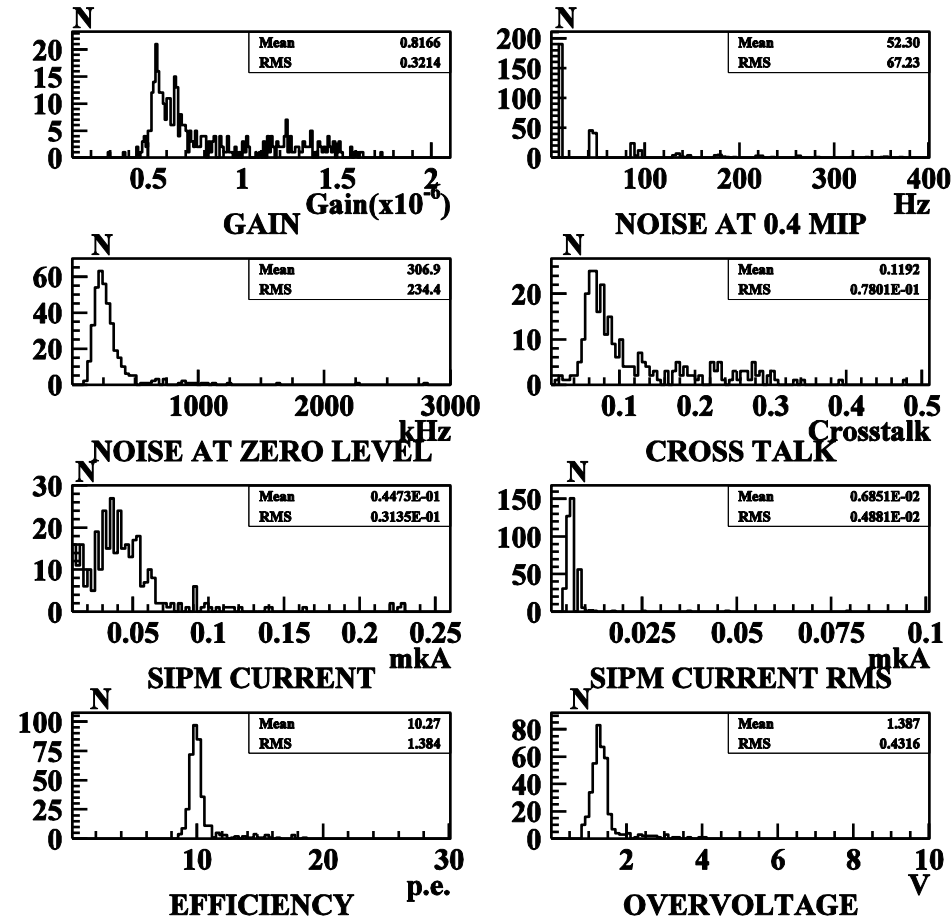
Tolerance is about  $100\mu\text{m}$ .

# Distribution of MRS APS parameters at operating bias voltage

## 556 pixel MRS APD

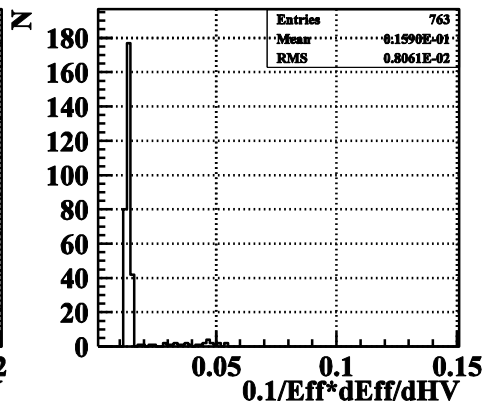
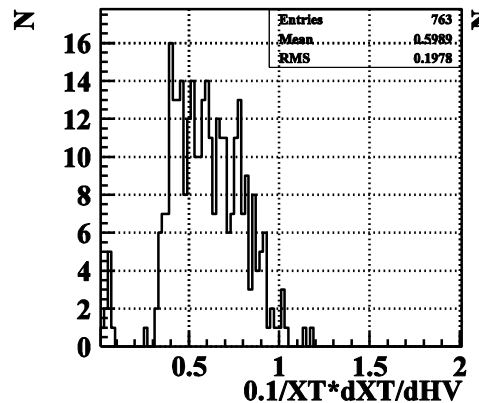
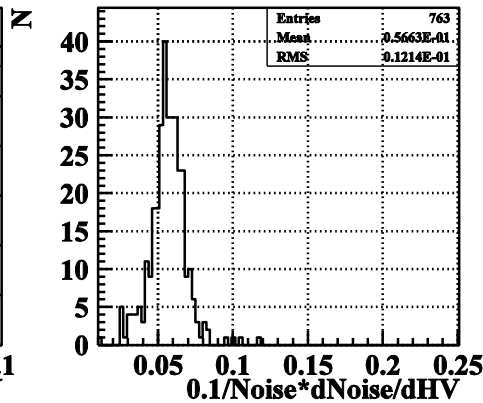
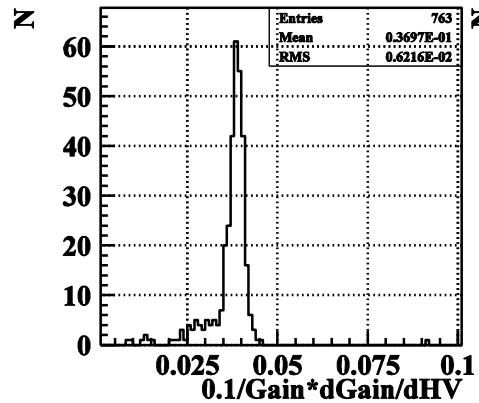


## 796 pixel MRS APD

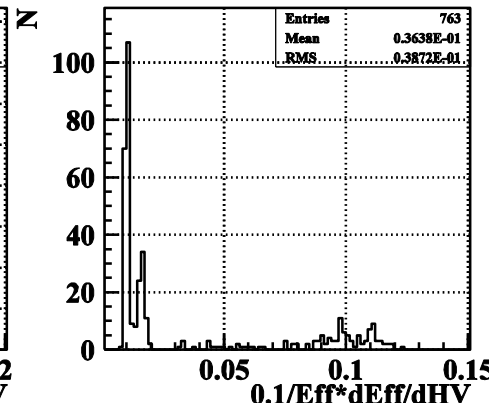
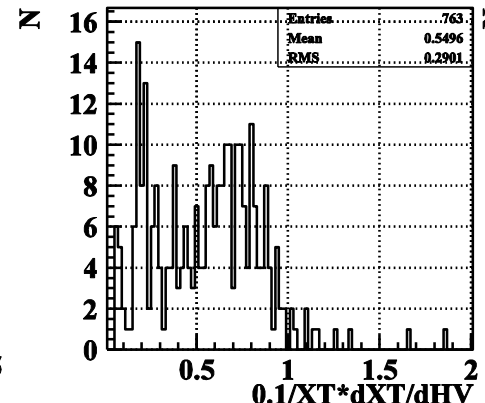
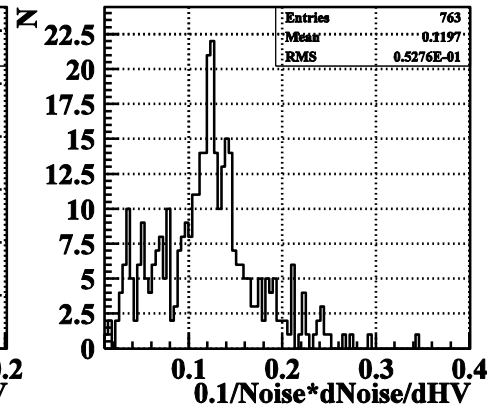
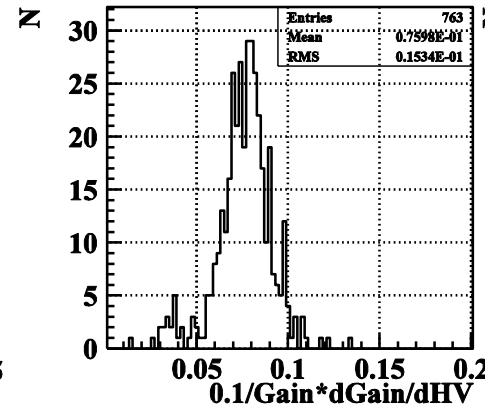


# Variation of APD MRS parameters at bias voltage variation

## 556 pixel MRS APD

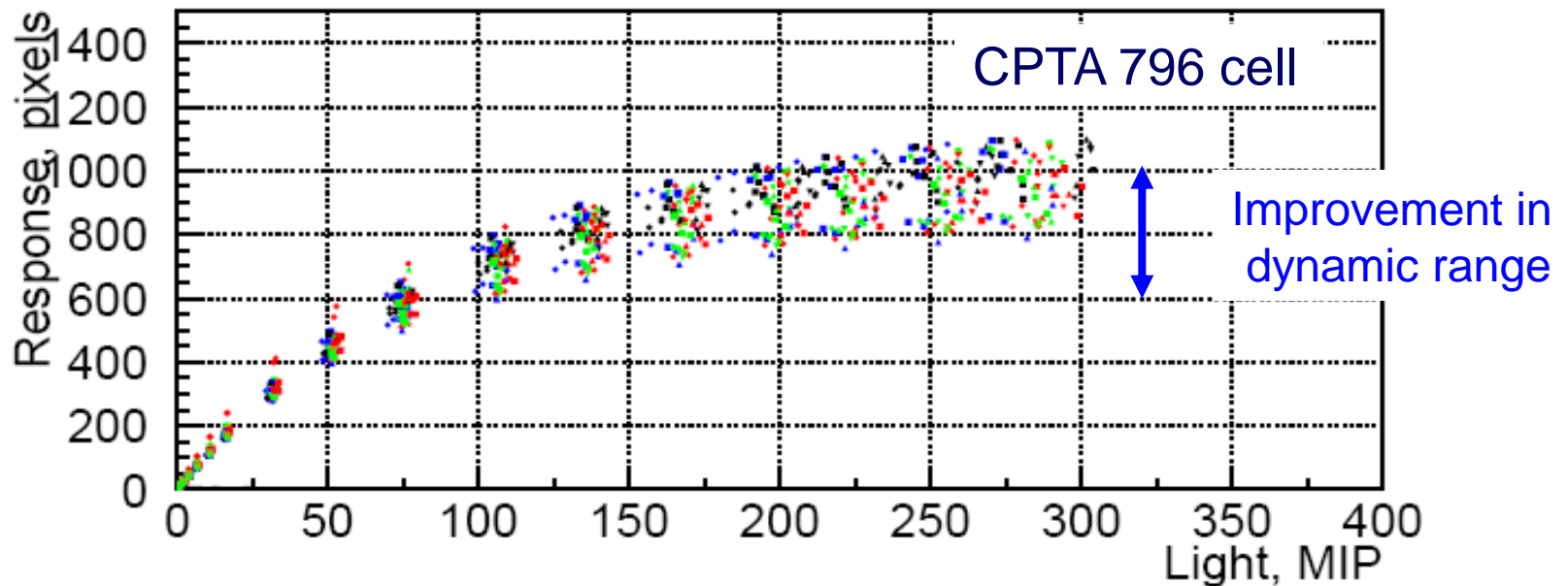
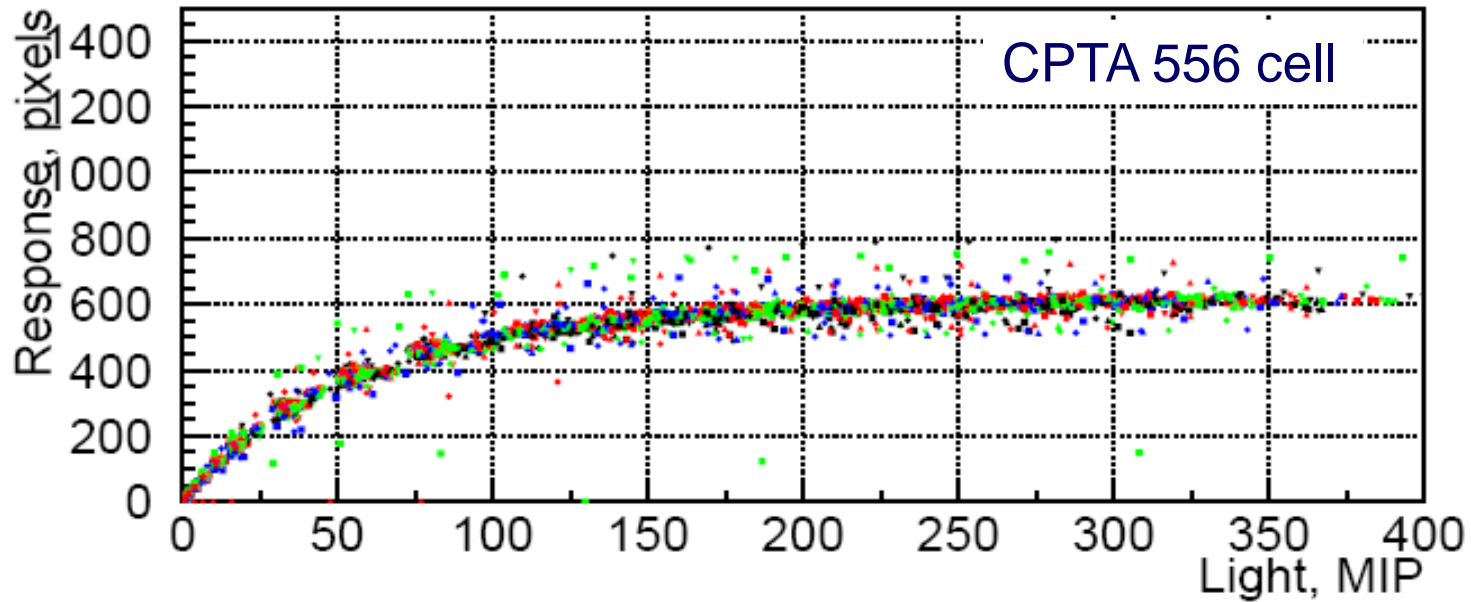


## 796 pixel MRS APD

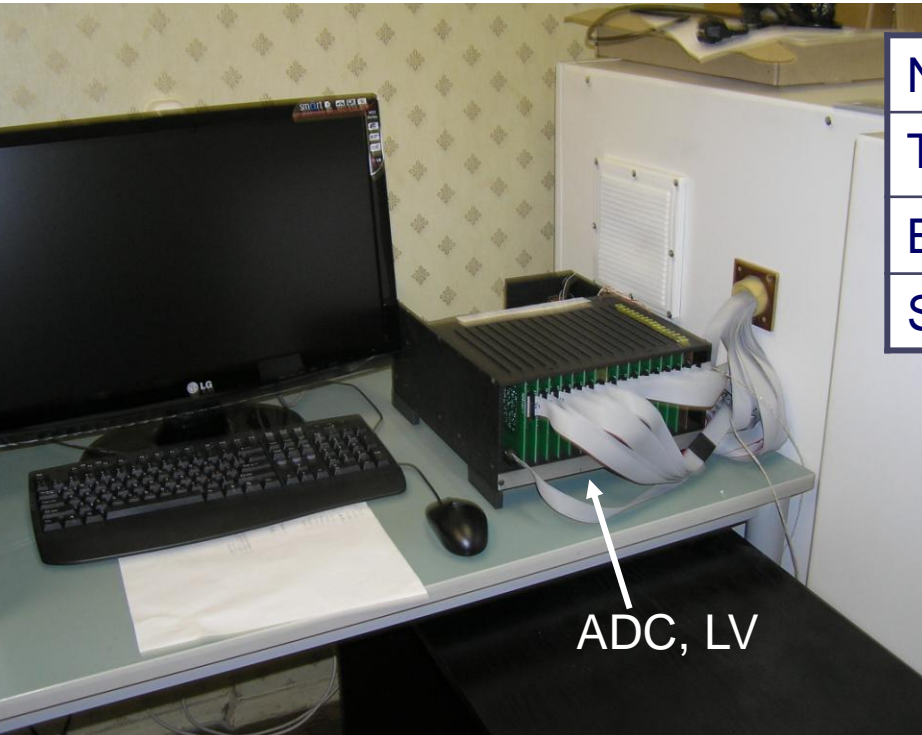


Larger sensitivity of 796 pixel SiPMs to  $\Delta V$  due to smaller overvoltage (because of too high efficiency!)

# SiPM saturation curves

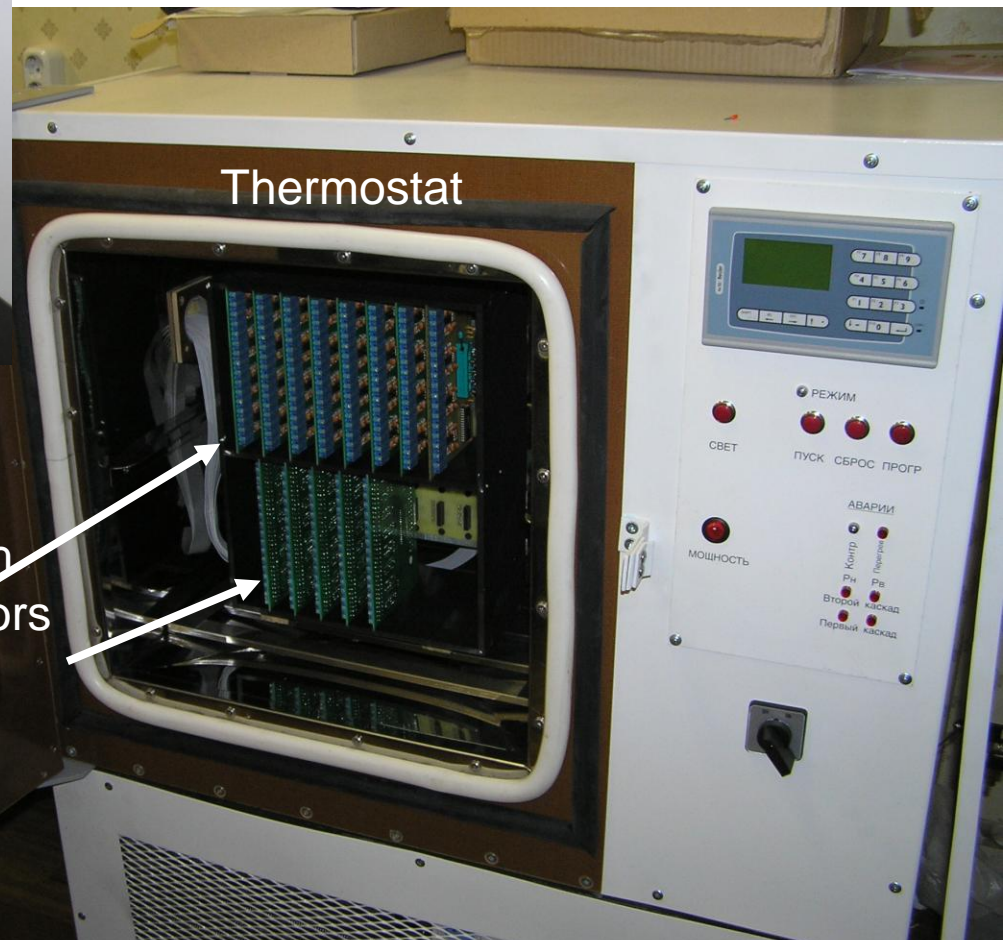


# Test of SiPM long term stability



ADC, LV

Number of channels	256
Temperature stability	0.2°C
Bias voltage accuracy	20mV
SiPM current measurement accuracy	1nA



Thermostat

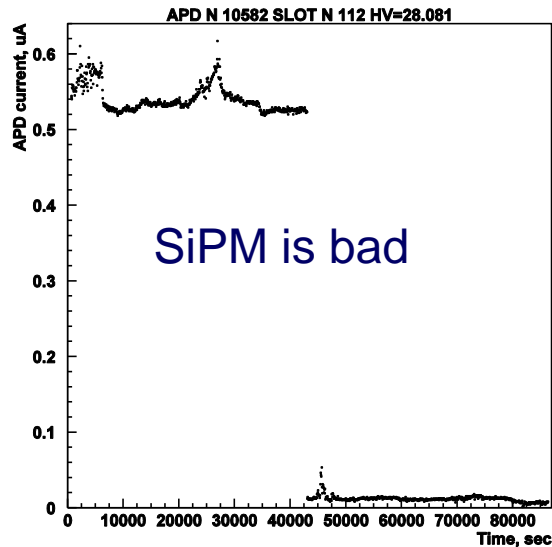
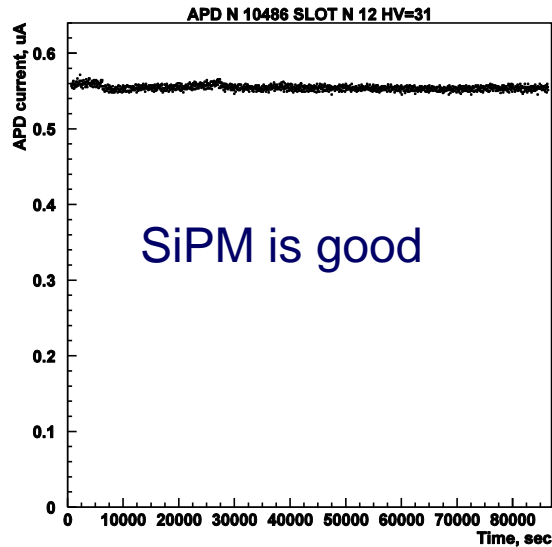
Boards with photosensors

@ elevated temperature +35°C  
for 3-4 days

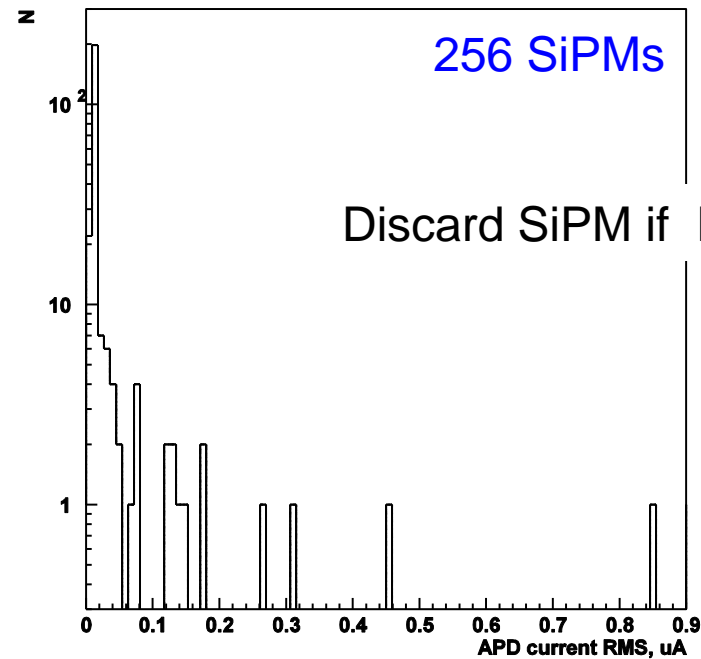
Setup commissioned.

# Test of SiPM long term stability (2)

Examples:



RMS of SiPM current over time

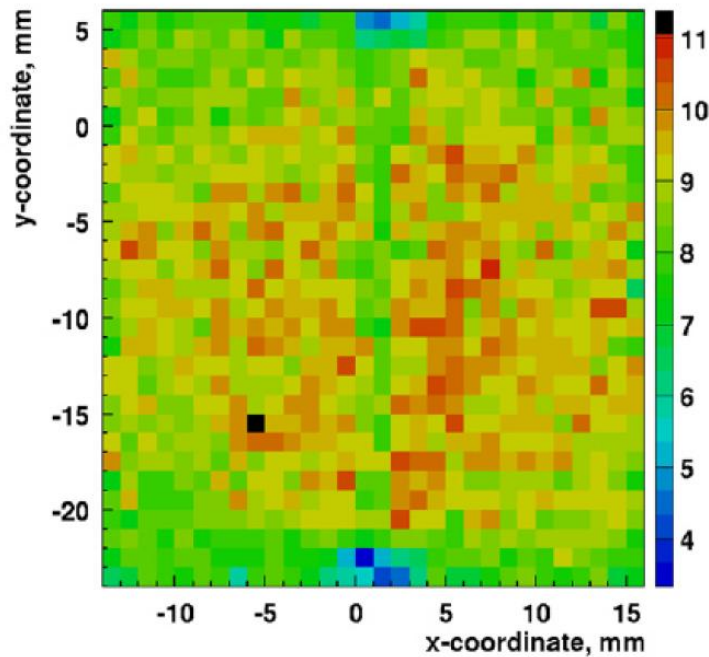


Yield of SiPMs is high.

# Efficiency and uniformity

Measurements at ITEP test beam

Response map



Geometrical efficiency is 98%.  
(will be even higher with silver paint mirror)

Total efficiency @ 10p.e./MIP and  
0.4 MIP threshold is about 96%.

Uniformity of response for 3mm thick tile is good.

# Conclusions

Scintillator tile – WLS fiber – SiPM system has been developed adequate for LC HCAL requirements.

**Scintillator tile :** thickness 3mm  
accuracy adequate  
technology is suitable for mass production

**SiPM :** low noise  
developed new package and new sensor  
ageing, long term stability OK

Efficiency for MIP registration is 96%, good uniformity of response.

20 fully equipped tiles delivered to DESY.  
~1000 to be delivered to DESY in Feb 2011.